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\*\* CONTINUING DATA \*\*\*\*\*  
 IA

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
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 REPUBLIC OF KOREA 2003-43087 06/30/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/27/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <i>[Signature]</i> Initials: <i>IA</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS  DRAWING 8	TOTAL  CLAIMS 15	INDEPENDENT  CLAIMS 2
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## TITLE

Method for fabricating gate-electrode of semiconductor device with use of hard mask

☐ All Fees

☐ 1.16 Fees ( Filing )